

B399

(12)

EUROPEAN PATENT SPECIFICATION

(45) Date of publication and mention of the grant of the patent:
16.01.2002 Bulletin 2002/03

(51) Int Cl.7: G01L 21/12

(21) Application number: 98102089.4

(22) Date of filing: 06.02.1998

(54) Pirani with heating only the resistive sensing element

Pirani, bei dem nur das Widerstandsfühlerelement beheizbar ist

Pirani dans lequel seule la résistance de mesure est chauffante

<div>(84) Designated Contracting States: BE CH DE FI FR GB IT LI NL SE</div> <div>(30) Priority: 21.07.1997 US 897629</div> <div>(43) Date of publication of application: 27.01.1999 Bulletin 1999/04</div> <div>(73) Proprietor: HELIX TECHNOLOGY CORPORATION Mansfield, Massachusetts 02048 (US)</div> <div>(72) Inventors:<ul style="list-style-type: none">• Billis, Daniel Granville Colorado 80303 (US)</div>	<div>• Borenstein, Michael Dale Colorado 80303 (US)</div> <div>(74) Representative: Schwepfinger, Karl-Helinz, Dipl.-Ing. Prinz & Partner GbR Manzingerweg 7 81241 München (DE)</div> <div>(56) References cited:<div>DE-A- 1 648 592DE-B- 1 094 341</div><div>US-A- 5 347 869US-A- 5 557 972</div><div>US-A- 5 597 957</div></div>
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EP 0 893 677 B1

Description

FIELD OF THE INVENTION

- 5 [0001] The present invention relates to a heat loss gauge utilizing gas conduction for measuring pressures, ranging from very low pressures to pressures greater than atmospheric pressure.

BACKGROUND OF THE INVENTION

- 10 [0002] Because the rate of heat transfer through a gas is a function of the gas pressure, under certain conditions measurements of heat transfer rates from a heated sensing element to the gas can, with appropriate calibration, be used to determine the gas pressure. This principle is used in the well known Pirani gauge (shown in schematic form in Figs. 1a and 1b), in which heat loss is measured with a Wheatstone bridge network which serves both to heat the sensing element and to measure its resistance.

- 15 [0003] Referring to Figure 1a, in a Pirani gauge the pressure sensor consists of a temperature sensitive resistance R_S connected as one arm of a Wheatstone bridge. R_2 is typically a temperature sensitive resistance designed to have a negligible temperature rise due to the current i_2 . R_3 and R_4 are typically fixed resistances. R_S and typically R_2 are exposed to the vacuum environment whose pressure is to be measured. Figure 1b illustrates an alternative bridge configuration.

- 20 [0004] Pirani gauges have been operated with constant current i , (as shown in U.S. Patent 3,580,081), or with constant voltage across R_S . In these methods, an electrical imbalance of the bridge is created which reflects gas pressure. Pirani gauges have also been operated with constant resistance R_S (as shown in U.S. Patent 2,938,387). In this mode, the rate at which energy is supplied is varied with changes in gas pressure, so the rate of change in energy supplied reflects changes in gas pressure. Each method of operation has differing advantages and disadvantages, but the following discussion pertains particularly to the constant resistance method and the configuration of Figure 1a.

- 25 [0005] Voltage V_B is automatically controlled to maintain the voltage difference between A and C in Fig. 1a at zero volts. When the potential drop from A to C is zero, the bridge is said to be balanced. At bridge balance the following conditions exist:

30
$$i_S = i_2, \quad (1)$$

35
$$i_4 = i_3 \quad (2)$$

and

40
$$i_S R_S = i_4 R_4, \quad (3)$$

$$i_2 R_2 = i_3 R_3 \quad (4)$$

- 45 Dividing Eq. 3 by Eq. 4 and using Eq. 1 and 2 gives

$$R_S = \beta R_2 \quad (5)$$

- 50 where

$$\beta = \frac{R_4}{R_3} \quad (6)$$

- 55 Thus, at bridge balance R_S is a constant fraction β of R_2 .

- [0006] To achieve a steady state condition in R_S at any given pressure, Eq. 7 must be satisfied:

Electrical power input to RS = Power radiated by RS +

Power lost out ends of RS + Power lost to gas by RS (7)

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[0007] A conventional Pirani gauge is calibrated against several known pressures to determine a relationship between unknown pressure, P_x , and the power loss to the gas or more conveniently to the bridge voltage. Then, assuming end losses and radiation losses remain constant, the unknown pressure of the gas P_x may be directly determined by the power lost to the gas or related to the bridge voltage at bridge balance.

10 [0008] Because Pirani gauges may be designed to have wide range and are relatively simple and inexpensive, there is a long-felt need to be able to use these gauges as a substitute for much higher priced gauges such as capacitance manometers and ionization gauges. However, existing designs leave much to be desired for accurate pressure measurement, especially at lower pressures.

15 [0009] Prior to 1977, the upper pressure limit of Pirani gauges was approximately 20 Torr due to the fact that at higher pressures the thermal conductivity of a gas becomes substantially independent of pressure in macroscopic size devices. One of the present inventors helped develop the CONVECTRON® Gauge produced and sold by the assignee (Granville-Phillips Company of Boulder Colorado) since 1977 which utilizes convection cooling of the sensing element to provide enhanced sensitivity from 20 to 1,000 Torr. Hundreds of thousands of CONVECTRON® Gauges have been sold worldwide. Recently several imitations have appeared on the market.

20 [0010] Although the CONVECTRON® Gauge filled an unsatisfied need, it has several disadvantages. It has by necessity large internal dimensions to provide space for convection. Therefore, it is relatively large. Because convection is gravity dependent, pressure measurements at higher pressures depend on the orientation of the sensor axis. Also, because the pressure range where gas conduction cooling is predominant does not neatly overlap the pressure range where convection cooling occurs, the CONVECTRON® Gauge has limited sensitivity from approximately 20 to 200 Torr.

25 [0011] To help avoid these difficulties, microminiature Pirani sensors have been developed which utilize sensor-to-wall spacings on the order of a few microns rather than the much larger spacings, e.g., 0.5 in., previously used. See for example U.S. Patents 4,682,503 to Higashi et al. and 5,347,869 to Shie et al. W. J. Alvesteffer et al., in an article appearing in J. Vac. Sci. Technol. A 13(6), Nov/Dec 1995, describe the most recent work on Pirani gauges known to the present inventors. Using such small sensor to wall spacings provides a pressure dependent thermal conductivity even at pressures above atmospheric pressure. Thus, such microscopic sensors have good sensitivity from low pressure to above atmospheric pressure and function in any orientation.

30 [0012] There are a number of problems with previous attempts to develop microminiature gauges. Although microminiature sensors provide good sensitivity over a large pressure range independent of orientation, their design is extremely complex and fabrication requires numerous elaborate processing steps in highly specialized equipment costing hundreds of thousands of dollars.

35 [0013] Microminiature sensors suffer from the same type of ambient temperature-caused errors as do macroscopic sensors. All of the heat loss terms in Eq. 7 are dependent on ambient temperature and on sensing element temperature at any given pressure. Thus, any attempt at pressure measurement with a Pirani gauge without temperature correction will be confused by non-pressure dependent power losses caused by changes in ambient temperature. All modern Pirani gauges attempt to correct for the errors caused by ambient temperature changes. A widely used means for correcting for such errors is to use for R2 a temperature sensitive compensating element RC in series with a fixed resistance R, as shown in Figs. 1a and 1b.

40 [0014] British Patent GB 2105047A discloses the provision of an additional resistor to provide a potential divider. J. H. Leck, at page 58 of Pressure Measurement in Vacuum, Chapman and Hall: London (1964) notes that Hale in 1911 made R2 of the same material and physical dimensions as RS in his Pirani gauge. R2 was sealed off in its own vacuum environment and placed in close proximity to RS. When the pressures at R2 and RS were equal, excellent temperature compensation was achieved. However, at other pressures this means of temperature compensation is not very effective.

45 [0015] To avoid the extra cost and complexity of evacuating and sealing off R2 in a separate bulb, R2 is conventionally placed in the same vacuum environment as RS. By making R2 with a relatively large thermal mass and large thermal losses, self heating of R2 can be made negligible. Leck recommends that R2 be "made in two sections, for example, one of copper and the other Nichrome wire . . . so that the overall temperature coefficient (of R2) just matches that of the Pirani element itself (RS)." According to Leck, this method of temperature compensation has been used by Edwards High Vacuum of Great Britain in the METROVAC® brand gauge. A similar temperature compensation arrangement is used in the CONVECTRON® brand gauge.

55 [0016] However, this technique (using two or more materials in R2 having different temperature coefficients of resistance to approximate the temperature coefficient of RS) is effective only over a narrow range of pressure. In fact the compensation can be made exact only at one, or at most several temperatures as noted in U.S. Patent 4,541,286,

which discloses this form of temperature compensation in a Pirani gauge. Also, the inventors have found that configurations with a large thermal mass significantly increase the response time of the gauge to sudden changes in ambient temperature.

[0017] The inventors have also found, through extensive computer simulation, that using equal temperature coefficients for RS and R2 as recommended by Leck and as practiced in the prior art does not provide an entirely accurate temperature compensation. The inventors have also found that at pressures less than approximately 5×10^{-3} Torr, the end losses exceed all other losses combined. The relative loss components as determined by this research (radiation loss, end loss and gas loss components of total loss) are shown in the graph of Fig. 2. At 1×10^{-5} Torr, the end losses are over 1000 times greater than the gas loss and radiation losses are approximately 100 times greater than the gas loss.

[0018] Therefore, temperature change effects in prior art Pirani Gauges are especially troublesome at very low pressures where gas conduction losses are very low. Prior art heat loss gauges cannot measure very low pressures accurately, for example, 1×10^{-5} Torr. The inventors have discovered that this limitation is a result of failure to maintain end losses in the sensing element sufficiently constant when ambient temperature changes. The Alvesteffer-type Pirani gauge has the capability of indicating pressure in the 10^{-5} Torr range, but does not provide an accurate indication within that range. For example, if the end losses are not held constant to one part in 5,000 in a typical Pirani gauge, a pressure indication at 1×10^{-5} Torr may be off by 50% to 100%.

[0019] The following analysis shows why prior art designs are ill-suited to correct adequately for ambient temperature changes at low pressures. For convenience in examining the prior art, the problems are explained using examples of gauges with relatively large spacing of sensor element to wall. It should be understood that the same type of problems exist in the much more complex geometries of microminiature gauges, with sensing element-to-wall spacings on the order of a few microns.

[0020] Fig. 3 is a schematic representation of a portion 302 of a conventional Pirani gauge using a small diameter wire sensing element 304 and a compensating element 303. Those familiar with Pirani gauge design will appreciate that the components in Fig. 3 are not shown to scale, for ease of explanation and understanding. Typically, small diameter wire sensing element 304 is electrically and thermally joined to much larger electrical connectors 306, 307 which are thermally joined to much larger support structures 308, 309. Let T_{AL} represent the temperature in support structure 308 at the left end of sensing element 304 and T_{AR} represent the temperature in support structure 309 at the right end at any given time t . Let T_{SL} and T_{SR} represent the temperatures at left sensing element connector 306 and right sensing element connector 307 respectively. Let T_{CL} and T_{CR} represent the temperatures at left compensating element connector 310 and right compensating element connector 311 respectively. Let T_{XL} and T_{XR} represent the temperatures a distance ΔX from connectors 306 and 307 respectively. In prior art designs, it has apparently been assumed that all of these temperatures are the same. However, the inventors have found that even seemingly negligible differences assume great importance for low pressure accuracy.

[0021] To better understand temperature compensation requirements, it is important to note several facts.

(1) At low pressures, the temperature of RC is determined predominantly by heat exchange between the compensating element connections and the compensating element. This is because at ambient temperature and low pressures, radiation and gas conduction are very inefficient means of exchanging heat from the compensating element to its surroundings relative to heat conduction through the ends of the compensating element. Thus, at low pressures the compensating element temperature will be very close to the average of the temperatures of the connectors at each end of the compensating element as shown in Eq. 8.

$$T_{AVG} = \frac{T_{CL} + T_{CR}}{2} \quad (8)$$

(2) The temperature of the electrically heated sensing element varies from the ends to center, increasing with distance from the cooler supports. Using finite element analysis the inventors have simulated the temperature distribution along the sensing element. It has been found that with equal temperature coefficients of resistance for RS and RC, the temperature T_n of any segment n of the sensing element changes with changes in average temperature T_{AVG} of the compensating element RC at constant pressure at bridge balance so as to maintain a constant difference $\Delta T_n = T_n - T_{AVG}$. The difference ΔT_n is a function of β and R where $R = R_2 - R_C$.

(3) According to Eq. 5, the sensing element resistance RS at bridge balance will be maintained at a resistance β times the resistance element R2. As the ambient temperature increases, the compensating element connectors also increase in temperature and thus the temperature and resistance of RC will increase according to Eq. 8. Any increase in the temperature and therefore the resistance of RC causes an increase in the temperature and resistance of all segments of RS at bridge balance.

(4) The power losses out the ends of the sensing element depend on the temperature gradient γ at the ends of the sensing element according to Eq. 9:

$$\text{Power lost out end} = k \gamma \quad (9)$$

where k is a constant and

$$\gamma_L = \frac{T_{XL} - T_{SL}}{\Delta X} \quad \text{at left end} \quad (10)$$

$$\gamma_R = \frac{T_{XR} - T_{SR}}{\Delta X} \quad \text{at right end.} \quad (11)$$

If γ_L and or γ_R vary for any reason, then the end losses will change and the pressure indication will be erroneous.

[0022] To understand in detail a significant deficiency in the prior art of temperature compensation at low pressures, assume that from a steady state, T_{AR} is increased slightly for example by changes in the local ambient temperature environment of the right support structure. Assume T_{AL} remains unchanged. Because T_{AL} is assumed not to change, T_{CL} and T_{SL} will remain unchanged. However, the increase in T_{AR} will cause T_{CR} to increase by conduction of heat through the connection. Thus, $T_{AVG} = \frac{T_{CL} + T_{CR}}{2}$ will increase. An increase in T_{AVG} will cause an increase in T_{XL} and T_{XR} at bridge balance, which will produce changes in γ_L and γ_R . These changes in γ_L and γ_R will change the end loss term in Eq. 7, causing an error in pressure measurement dependent on the size of the changes in γ_L and γ_R .

[0023] The inventors have determined that unless T_{AL} changes in substantially the same way as T_{AR} , sensing element end losses will not remain unchanged whenever ambient temperature changes. Prior art Pirani gauges have not been specifically designed to maintain $T_{AL} = T_{AR}$ to the degree necessary for accurate low pressure measurement.

[0024] To understand another important deficiency in prior art temperature compensation, assume that from a steady state, ambient temperature is increased and that ambient temperature conditions are such that $T_{AL} = T_{AR}$. Further assume the sensing element connectors are of equal length but that the right compensating element connector is substantially longer than the left compensating element connector as is the case in a popular prior art Pirani gauge. Thus, $T_{SL} = T_{SR}$ but T_{CR} will lag behind T_{CL} because of the assumed differences in length. During this lag time when $T_{CL} \neq T_{CR}$, T_{AVG} will change, thus changing T_{XL} and T_{XR} at bridge balance. Thus, γ_L and γ_R will continually change during the lag time, producing errors in low pressure indication.

[0025] The inventors have determined that unless the sensing element and compensating element connectors have substantially identical physical dimensions and substantially identical thermal properties, sensing element end losses will not remain unchanged when ambient temperature changes. Prior art Pirani gauges have not been specifically designed so that sensing and compensating element connectors have identical physical dimensions and thermal properties.

[0026] Another significant deficiency arises (as the inventors have discovered) from differences in mass between the compensating element and the sensing element. Assume that the mass of the compensating element is substantially larger than that of the sensing element as is typically the case. With prior art Pirani gauges it is common practice to make the compensating element large relative to the sensing element and to provide a relatively large heat loss path to the compensating element surroundings so that the heat arising from dissipation of electrical power in RC can be readily dispersed. From a steady state, assume that ambient temperature increases and that $T_{AL} = T_{AR}$ at all times. Thus, it will take a longer time for the compensating element to reach a new steady state temperature relative to the time it will take T_{SL} and T_{SR} to reach a new steady state temperature. During this time (which has been observed to be of several hours duration in a popular prior art Pirani gauge) T_{AVG} will continually change, thus continually changing T_{XL} and T_{XR} at bridge balance. Thus, γ_L and γ_R will change during the lag time, sensing element end losses will not remain constant, and errors will be produced in low pressure measurement.

[0027] The same type of problems occur if the compensating element is designed to change temperature at a different rate than does the sensing element with change in ambient temperature at bridge balance. Prior art designs such as the Alvesteffer-type device have this deficiency.

[0028] From their research, the inventors have determined that, unless the compensating element has been designed to change temperature at the same rate as the sensing element, sensing element end losses continue to change long after ambient temperature has stabilized at a new value. Yet, prior art Pirani gauges have not been designed to meet this requirement.

[0029] It has long been known to use for R2 a compensating element RC, with substantially the same temperature coefficient of resistance as the sensing element, in series with a temperature insensitive resistance element R so as to provide temperature compensation for gas losses and end losses which vary as the temperature difference between the sensing element and its surroundings. This method of temperature compensation has been employed in the CON-VECTRON® Gauge for many years and is also used in the Alvesteffer gauge.

[0030] This method of temperature compensation assumes that if (1) the temperature coefficients of resistance of the sensing and compensating elements are equal; and (2) the change in sensing element resistance can be made to rise in tandem with change in compensating element resistance, then (3) the temperature of the sensing element will rise in tandem with ambient temperature changes. Satisfying these two assumptions is highly desirable, of course, because doing so would assure that the temperature difference between the heated sensing element and the surrounding wall at ambient temperature would remain constant as ambient temperature changes.

[0031] However, the inventors have found that prior art gauges which utilize a constant resistance R in series with a temperature sensitive resistance RC for R2 provide only partial temperature compensation as will now be explained.

[0032] Assume that in Fig. 1a, R2 is composed of a temperature sensitive compensating element RC and a temperature insensitive resistance R so that

$$R2 = RC + R \quad (12)$$

Thus, Eq. 5 derived above for bridge balance may be written as

$$RS = \beta (RC + R) \quad (13)$$

where β is defined by Eq. 6 above.

[0033] Further, assume when the ambient temperature environment of the gauge is equal to T_1 that the sensing element operates at temperature T_{S1} and the compensating element operates at temperature T_{C1} . Thus when

$$T_{\text{AMBIENT}} = T_1 \quad (14)$$

Eq. 13 may be written as

$$RS(T_1)(1 + \alpha_S (T_{S1} - T_1)) = \beta [RC(T_1) (1 + \alpha_C (T_{C1} - T_1)) + R] \quad (15)$$

Here, $RS(T_1)$ is the resistance of the sensing element at temperature T_1 , α_S is the temperature coefficient of resistance of RS at T_1 , $RC(T_1)$ is the resistance of the compensating element at temperature T_1 , and α_C is the temperature coefficient of resistance of R_C at T_1 . Thus, when

$$T_{\text{AMBIENT}} = T_2$$

Eq. 13 may be written as

$$RS(T_1) (1 + \alpha_S (T_{S2} - T_1)) = \beta [RC(T_1) (1 + \alpha_C (T_{C2} - T_1)) + R] \quad (16)$$

Solving Eq. 15 for T_{S1} gives

$$T_{S1} = \left[\frac{\beta}{RS(T_1)} [RC(T_1)(1 + \alpha_C (T_{C1} - T_1)) + R] - 1 \right] / \alpha_S + T_1 \quad (17)$$

Solving Eq. 16 for T_{S2} gives

$$T_{s2} = \left[\frac{\beta}{RS(T_1)} [RC(T_1)(1 + \alpha_c(T_{c2} - T_1)) + R] - 1 \right] / \alpha_s + T_1 \quad (18)$$

Subtracting Eq. 17 from Eq. 18 gives the temperature change ΔT in the sensing element RS when ambient temperature changes from T_1 to T_2 . Thus,

$$\Delta T = T_{s2} - T_{s1} = \beta \left(\frac{RC(T_1)}{RS(T_1)} \right) \left(\frac{\alpha_c}{\alpha_s} \right) (T_{c2} - T_{c1}) \quad (19)$$

Note that an effective compensating element is designed so that its temperature closely follows ambient temperature. Thus, to a very good approximation,

$$T_{c2} - T_{c1} = T_2 - T_1$$

or

$$T_{c2} - T_{c1} = T_2 - T_1 \quad (20)$$

Thus, Eq. 19 may be written as

$$\Delta T = \beta \left(\frac{RC(T_1)}{RS(T_1)} \right) \left(\frac{\alpha_c}{\alpha_s} \right) (T_2 - T_1) \quad (21)$$

It is evident from Eq. 21 that the temperature change ΔT in the sensing element RS will be equal to the change in ambient temperature $T_2 - T_1$ only if

$$\beta \left[\frac{RC(T_1)}{RS(T_1)} \right] \left[\frac{\alpha_c}{\alpha_s} \right] = 1 \quad (22)$$

Prior art gauges using a temperature sensitive compensating element RC in series with a fixed resistance R for R2 in Fig. 1a provide only partial temperature compensation depending on the choice of β . Commercially available gauges having the design described by Alvesteffer et al., the most recent work on Pirani gauges known to the present inventors, would not satisfy Eq. 22.

[0034] As a third problem with prior art gauge designs, the inventors have found that the level of power dissipation in R2 adversely affects accuracy. Prior art Pirani gauges, when configured as in Fig. 1a, have the same pressure dependent current in RS as is in the compensating element at bridge balance. When configured as in Fig. 1b, at balance

the same pressure dependent voltage is applied across R2 as across RS. Of course, a pressure dependent current in R2 will cause the temperature of RC to rise above ambient temperature by an amount which varies with pressure.

[0035] Prior art Pirani gauges typically use a compensating element of much larger physical dimensions than the sensing element, to dissipate the heat and thus prevent excessive temperature in the compensating element. As noted above, different physical dimensions for the sensing and compensating elements cause measurement errors when ambient temperature changes.

[0036] A fourth problem is that prior art Pirani gauges produce shifts in pressure indications at low pressures when ambient temperature changes. Prior art Pirani gauges have used a variety of components in attempting to maintain the power lost by the sensing element unchanged as ambient temperature changes. For example, in U.S. Pat. 4,682,503 thermoelectric cooling is used to control ambient temperature and thus minimize ambient temperature changes.

[0037] In the device disclosed in U.S. Pat. 4,541,286, a thermally sensitive element is mounted adjacent to the compensating arm of the bridge (actually glued to the exterior of the vacuum enclosure in a commercial version). Alvesteffer et al. use an additional element (designated therein as R4) in the bridge to help compensate for the fact that the temperature coefficient of resistance is slightly different for the sensing element at operating temperature, compared to the compensating element at ambient temperature. Although each of these prior art hardware fixes remove some of the errors caused by changes in ambient temperature, none of them removes substantially all of the errors. Thus prior art Pirani gauges produce significant shifts in pressure indications at low pressures when ambient temperature changes.

[0038] Another prior system, disclosed in U.S. Patent 5,608,168, links various electrical measurements of the bridge (or approximations thereof) and determines the value or temperature of the temperature dependent resistance, and takes this parameter into account in determining the pressure measurement. However, this system has increased complexity because of the need to measure temperatures or other values.

[0039] Thus, there is a need for an improved Pirani-type gauge which overcomes these problems.

SUMMARY OF THE INVENTION

[0040] Therefore, it is a general objective of the invention to provide improved apparatus and operating methods for heat loss pressure measurement, comprising the features defined in claim 1.

[0041] Another, more specific objective of the invention is to provide an improved Pirani-type pressure gauge wherein a compensating element has physical dimensions substantially equal to those of a sensing element and is located in spaced relationship to the sensing element, in the same plane as the sensing element, and is made of the same material as the sensing element.

[0042] A further objective of the invention is to provide an improved heat loss pressure gauge with thermally conductive elements placed near a sensing element to equalize temperatures across the sensing element.

[0043] Another objective of the invention is to provide an improved heat loss pressure gauge including a means for maintaining a desired spacing between the sensing element and thermally conductive elements to compensate for expansion and contraction of the sensing element in response to changes in ambient temperature.

[0044] Another objective is to provide an improved heat loss pressure gauge that uses a DC heating voltage.

[0045] An additional objective of the invention is to provide a heat loss pressure gauge using a bridge circuit with two fixed elements, a sensing element, and a compensating element, wherein resistance of one fixed bridge element multiplied by resistance of the compensating element at a given temperature multiplied by a temperature coefficient of the compensating element for that temperature is substantially equal to the resistance of the other fixed bridge element multiplied by resistance of the sensing element multiplied by the temperature coefficient of the sensing element for the given temperature.

[0046] These objectives and others are achieved in the present invention by providing a variety of improvements which cooperate synergistically to provide significantly improved low, mid-range and high pressure measurement accuracy, thus, permitting the range of accurate pressure measurement to be extended to lower and to higher pressures within a single gauge.

[0047] In a preferred embodiment of the invention, a small diameter wire sensing element is positioned in the same plane as and spaced from a small diameter wire compensating element with two parallel flat thermally conductive plates, each spaced 15 microns from the sensing and compensating elements. In this manner, the inventors have achieved high relative sensitivity in simple geometry without relying on convection. The extreme complexity and cost of microminiature Pirani gauge designs and the several disadvantages of convection cooling of the sensing element are simultaneously avoided.

[0048] The inventors have found that this extremely simple, small, and inexpensive measuring means gives results up to atmospheric pressure comparable to those obtained with very complex microminiature Pirani gauges and to those obtained with much larger, position-sensitive convection-cooled Pirani gauges. Surprisingly, this improvement

also provides a sensing element with a volume of only 3% that of the sensing element in the microminiature Alvesteffer gauge. The compensating element in the new device has a volume of less than 0.5% of the Alvesteffer-type compensating element.

[0049] The present invention also provides improved temperature correction. The inventors have found that the accuracy of low pressure measurement can be significantly improved by better maintaining constant the temperature gradient γ at the ends of the sensing element (see Eqs. 10 and 11). The inventors have found that constancy of γ can be achieved by simultaneously:

1. Using sensing and compensating elements with substantially identical physical dimensions, thermal properties and resistance properties;
2. Using sensing element and compensating element connections with substantially identical physical dimensions, thermal properties and resistance properties;
3. Using element connections with substantially identical and large thermal conductances to a region of substantially uniform temperature for all connections; and
4. Locating the sensing and compensating elements in the same vacuum environment.

In the present invention Eq. 22 is satisfied at all times because the gauge is designed so that

$$RC(T_A) = RS(T_A) \quad (23)$$

where T_A is ambient temperature, and where

$$\alpha_C = \alpha_S \quad (24)$$

$$\beta = 1 \quad (25)$$

[0050] A significant improvement is realized by providing negligible heating in the compensating element. The inventors have modified the conventional Wheatstone bridge to provide independent heating means for the sensing element, while producing substantially zero heating in any of the other three arms of the bridge. Thus, the compensating element can be made with identical dimensions of the sensing element as well as identical physical properties. A DC heating current is used and confined to only the sensing element. A relatively small AC signal is used to sense bridge balance.

[0051] In this manner, the present invention provides significant advancements in Pirani gauge accuracy, production cost, and package size.

BRIEF DESCRIPTION OF THE DRAWINGS

[0052]

Figures 1a and 1b are simplified schematic diagrams of conventional Pirani gauges;

Figure 2 is a graph showing the components of heat loss in a conventional Pirani gauge, as discovered through the inventors' research;

Figure 3 is a schematic representation of a conventional Pirani Gauge using a small diameter wire for the sensing element;

Figure 4a is a portion of an improved heat loss gauge according to the present invention, and Figure 4b is a cross-sectional view of the portion shown in Figure 4a;

Figure 5a is an enlarged cross-sectional view of the ends of an improved heat loss gauge according to the present invention, showing support and connection of sensing and compensating elements;

Figure 5b is a cross-sectional view showing one embodiment of a mechanism according to the present invention for maintaining spacing between heat conducting plates and a sensing element and compensating element, respectively; and

Figure 6 is a schematic diagram showing an independent heating arrangement for a sensing element according to the present invention.

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

[0053] The invention will be described in terms of four categories of improvements to conventional Pirani gauge designs. In a particularly preferred embodiment, the four improvements are used together, and combine synergistically to provide a Pirani gauge having substantially improved performance characteristics.

Improvement 1

[0054] The first category of improvements will be discussed with reference to Figures 4a and 4b. Figure 4a is a side view of a portion 10 of an improved heat loss gauge (not to scale). Figure 4b is a sectional view of portion 10 taken along line 4b-4b in Figure 4a. As shown in Figures 4a and 4b, a small diameter wire sensing element 12 is located in the same plane and spaced a distance d from a small diameter wire compensating element 14. Spacing d between sensing element 12 and compensating element 14 is preferably approximately 0.030 in. but may range from 0.010 in. to 0.200 in. Parallel plates 16 and 16' are provided proximate to and parallel to sensing element 12 and compensating element 14.

[0055] Parallel plates 16 and 16' are positioned a distance S from sensing element 12 and compensating element 14. S is preferably 0.0007 in. but may range from 0.0002 in. to 0.002 in. Sensing element 12 is made of a material with a high temperature coefficient of resistance, such as pure tungsten, which may be gold plated to help assure a constant emissivity.

[0056] The diameter of sensing element 12 is preferably 0.0005 in. but may range from 0.0001 in. to 0.002 in. Although a cylindrical wire shape is preferred, other shapes such as a ribbon may be used for both the sensing and compensating elements. The length of sensing element 12 is preferably 1 in. but may range from 0.25 in. to 3 in.

[0057] Compensating element 14 is made of the same material as the sensing element 12 with the same physical dimensions, and with the same thermal and resistance properties.

[0058] Portion 10 of the heat loss gauge may be installed in a measuring circuit of the type shown in Fig. 6, in a manner which will be described in more detail below.

[0059] Parallel plates 16 and 16' conduct heat and thereby tend to equalize temperature gradients along heated sensing element 12 and between the ends of sensing element 12 and compensating element 14. In this manner, the invention achieves high relative sensitivity with a simple structure, and without relying on convection. In this embodiment of the invention, the accuracy of low pressure measurement is significantly improved by using sensing and compensating elements with substantially identical physical dimensions, thermal properties and resistance properties, and locating the sensing and compensating elements in the same vacuum environment. Using this design, the extreme complexity and cost of microminiature Pirani gauge designs and disadvantages associated with convection cooling of the sensing element are simultaneously avoided. This improvement permits pressure measurement results up to atmospheric pressure comparable to those obtained with very complex microminiature Pirani gauges, and comparable to those obtained with much larger, position sensitive convection cooled Pirani gauges.

Improvement 2

[0060] As a second broad feature of the invention, an improved mounting arrangement is provided for the sensing and compensating elements. The accuracy of low pressure measurement is significantly improved by using sensing element and compensating element connections with substantially identical physical dimensions, thermal properties and resistance properties, and by using element connections with substantially identical and large thermal conductances to a region of substantially uniform temperature for all connections.

[0061] Fig. 5a is a greatly enlarged cross-sectional view of one end of gauge portion 10 where the sensing element 12 is supported by and electrically connected to sensing element connectors 20 and 20' and the compensating element 14 is shown supported by and electrically connected to compensating element connectors 22 and 22'. The section of Fig. 5a is taken along line 5a-5a in Figure 4a. Preferably, identical supports (as shown in Fig. 5a) are provided at each end of gauge portion 10.

[0062] Connectors 20, 20', 22 and 22' are preferably made of platinum ribbon, 0.001 in. thick by 0.060 in. wide. Plates 16 and 16' are preferably made of an electrically insulating material with a high thermal conductivity such as aluminum nitride.

[0063] Alternatively, sensing and compensating element connectors 20, 20', 22 and 22' can be electrically insulated from the plates 16 by thin electrically insulating layers 24 and 24' which may be a diamond-like coating on tungsten. In this case, Plates 16 and 16' may be made of a high thermal conductivity material such as tungsten. Preferably, the selected material has a thermal conductivity greater than 0.25 watts/cm/K.

[0064] Plates 16 and 16' are held in position by simple sheet metal clamps at each end (not shown). The clamps apply sufficient force to the plates 16 and 16' to embed the sensing element 12 and the compensating element 14 into

the connectors 20, 20', 22 and 22' until the connectors 20 and 20', and 22 and 22' are in intimate contact. Thus, the spacing S between the sensing element 12 and the surface of the plates 16 and 16' is determined by the diameter of the sensing element and the thickness of the thin ribbon connectors 20, 20', 22, and 22'. This feature of the present invention permits a sensing element smaller than a human hair to be spaced a comparable distance from two flat surfaces, precisely and very inexpensively as well as providing electrical connections to additional circuitry.

[0065] Plates 16 and 16' provide a region of substantially uniform temperature, especially when isolated in vacuum with minimal thermal conductivity to the outside world. The thin ribbon connectors 20, 20', 22 and 22' provide identical dimensions, short path and very large thermal conductances to said region of uniform temperature, thus satisfying several of the conditions for constancy of temperature gradient, γ , at the ends of the sensing element.

[0066] Sensing element 12 may be suitably tensioned as shown in Fig. 5b by a small diameter wire spring 26 which is loaded during assembly and bears on sensing element 12 adjacent to said connector 21 of sensing element 12. Spring 28 is used in a similar manner to tension the compensating element 14. Springs 26 and 28 serve to maintain precise spacing of the sensing element 12 and compensating element 14 relative to plates 16 and 16' as ambient temperature changes. Sufficient slack must be built into the sensing element 12 and compensating element 14 assemblies to prevent breakage due to differential thermal expansion of the elements 12 and 14 and the plates 16. Without the springs 26 and 28, this slack would change with ambient temperature, thus preventing maintenance of constant spacing S between the parallel plates 16 and 16' and the sensing and compensating elements, respectively, and causing measurement errors.

[0067] In the design according to this embodiment of the invention, Eq. 22 is partially satisfied by the fact that sensing element 12 and compensating element 14 are physically, electrically, and thermally identical. In addition, R3 is set equal to R4 in the embodiment of Fig. 6, which from Eq. 6 assures that $\beta = 1$. Thus, Eq. 22 is fully satisfied at all times by this design.

Improvement 3

[0068] A third major feature of the invention is an apparatus and method for independently heating sensing element 12. This improvement is illustrated in Fig. 6 wherein a Wheatstone bridge 30 is modified to provide independent heating of sensing element 12. Prior art circuits, used with a compensating element with the same physical dimensions and made of the same material as the sensing element as in the present invention, cause the compensating element to operate not at ambient temperature but at the same temperature as the sensing element. Thus, Pirani gauges with the inventive improvements described above cannot achieve their accuracy potential using prior art heating circuits.

[0069] Referring now to Fig. 6, a Wheatstone bridge 30 with nodes A, B, C, and D is provided with sensing element 12 having resistance value R_S, connected between nodes B and C. Non-temperature sensitive resistance element 15 (having resistance R) and compensating element 14 (having resistance R_C) together make up resistance R₂. R₂ and capacitor 36 are connected in series order between nodes C and D. Resistor 17 having value R₄ is connected between nodes A and B, and resistor 19 having value R₃ is connected between nodes A and D. Vacuum environment 34 encloses sensing element 12 and compensating element 14. AC voltage source 38 is connected between nodes B and D, and frequency selective detector 40 is connected between nodes A and C. DC current source 32 is connected between nodes B and C to provide current to node B. Controller 42 is connected, via automatic feedback linkages 46 and 47, so as to control DC current source 32 and so as to receive a voltage detection input from frequency selective detector 40 for purposes of that control.

[0070] Vacuum environment 34 encloses a portion 10 (as shown in Figures 4a and 4b and described above with reference to those Figures) comprising sensing element 12, compensating element 14, and plates 16 and 16'. In addition, the assembly method described previously with reference to Figs. 5a and 5b is preferably used in the circuit of Fig. 6. Element connectors 20 and 20' at one end of sensing element 12 (shown in Fig. 5a) are electrically connected to Point C in bridge circuit 30 of Fig. 6, while sensing element connectors 21 and 21' (not shown) at the other end of sensing element 12 are electrically connected to Point B in Fig. 6. Compensating element connectors 22 and 22' at one end of compensating element 14 (shown in Fig. 5a) are electrically connected through capacitor 36 to Point D in Fig. 6, while the other end of compensating element 14 is connected to compensating element connectors 23 and 23' which are connected through a resistance 15 to Point C.

[0071] As shown in Fig. 6, DC current source 32 furnishes heating current I to sensing element 12 which is located in the vacuum environment 34. A capacitor 36 is provided as a means for preventing current from current source 32 from being present in R₂, R₃ and R₄. Thus, unlike prior art Pirani gauges using a conventional Wheatstone bridge, no portion of the heating current or heating voltage in R_S is present in R₂ at any time.

[0072] AC voltage source 38 applies an AC signal voltage to bridge 30 producing AC signal currents i_s , i_2 , i_3 , and i_4 . Using very small values for i_s , i_2 , i_3 , and i_4 and frequency selective detector 40, bridge balance can be detected with negligible heating produced in any arm of bridge 30. The DC current I from source 32 is automatically adjusted by controller 42, so as to continually assure that the AC voltage drop $i_s R_S$ from point B to C is equal to the voltage drop

$i_4 R_4$ from B to A as measured by the AC voltage detecting function of frequency selective detector 40. This automatic feedback linkage is indicated by dashed lines 46 and 47.

[0073] Processor 51 is connected to current meter 49 and to voltage meter 48, and produces an output indicative of pressure in the vacuum environment 34 based on the level of heating current and through sensing element 12 and the voltage drop across sensing element 12.

[0074] Thus, compensating element 14 may be made with the same physical dimensions and thermal and resistance properties as sensing element 12 and still operate at ambient temperature without any pressure dependent electrical heating.

10 Improvement 4

[0075] A fourth improvement will be described with reference again to Fig. 6. In this improvement, an improved apparatus and method are provided for calibrating and operating the Pirani gauge according to the present invention.

15 [0076] The inventors have discovered that an accurate indication of an unknown pressure P_x at bridge balance may be calculated from a simple equation of the form of Eq. 26.

$$P = f(VS, IS) \quad (26)$$

20 This finding differs from more conventional approaches. Pressure indication has been considered to depend not only on resistance of the sensing element, but also on other factors such as ambient temperature. Thus, conventional calibration schemes often require measurements of resistance and other quantities, both for calibration and during operation. However, the inventors have discovered that when the improvements described above are made, the values of VS and IS incorporate sufficient temperature information to produce an accurate pressure output, so that it is possible to eliminate the steps of separately measuring other parameters such as ambient temperature. In this manner, it is possible to use a three dimensional calibration table to determine pressure based on voltage and current alone.

25 [0077] In order to calibrate the gauge shown in Fig. 6, sensing element 12 is exposed to a series of known representative pressures and ambient temperatures spread over the pressure and temperature ranges of interest. The voltage drop, VS_C , as measured by voltmeter 48 and the current, IS_C , as measured by current meter 49 are recorded together at bridge balance with each of the known representative calibration pressures, P_C . These values may be recorded by a program operating in processor 51 or may be transferred to another processing unit for calibration calculations. The pressure P_C is plotted against voltage VS_C and current IS_C . Each series of measurements at a given calibration temperature produces a constant temperature function relating pressure to voltage and current. Significantly, as noted above, the inventors have discovered that these constant temperature functions can be usefully combined in a single three-dimensional data table to define a single calibration function of the form of Eq. 26. When this is done, the result is a series of points defining a surface, where the height of the surface is the pressure and is a function of measured voltage and current values.

30 [0078] The resulting calibration data may be stored in a lookup table and measured pressures can be determined by interpolating between pressure values stored in the lookup table based on the measured voltage drop and current. However, because of the number of points that must be stored to produce accurate output over a wide range of pressures, in the preferred embodiment, an approximating equation is obtained for the surface on which the measured values lie. This can readily be accomplished using three-dimensional surface plotting software. The resulting equation is of the form shown in Eq. 26. Then, to measure an unknown pressure P_x at any temperature, VS_x is measured by voltmeter 48 and IS_x is measured by current meter 49 at bridge balance. The correct value of pressure can then be readily obtained by substitution in Eq. 26 giving

$$P_x = f(VS_x, IS_x) \quad (27)$$

50 For convenience, Eq. 27 can be stored in processor 51 which can then be used to automatically calculate P_x when VS_x and IS_x are input to processor 51.

55 [0079] Those skilled in the art will appreciate that other quantities could be substituted for voltage and current within the scope of this invention. For example, a function of the form $P_x = g(W, R)$ where W is power applied to sensing element 12 and R is the resistance of sensing element 12 could be used in place of Equation 27. In this case, W and R can be calculated from the output of voltmeter 48 and current meter 49. What is important is that the two selected parameters include information relating to both current and voltage, such that the effects of changes in current and voltage will be differentially reflected in the calibration graph or table created based on values of the two parameters.

Thus, for example, the two input parameters for the function may be any two of a group including: power, current, voltage, and resistance. To generalize, it is possible to identify an equation of the form

$$P = h(X, Y)$$

which approximates the calibration surface, where X is the first input parameter, Y is the second input parameter, and P is the pressure corresponding to values of the first parameter X and second parameter Y. This equation is then used as a proxy for the multi-dimensional calibration surface to calculate the pressure.

[0080] This improvement provides excellent temperature compensation from 0°C to 50°C from pressures less than 10⁻⁴ Torr to above atmospheric pressure. It avoids the need to measure power and temperature as is sometimes done. It compensates for all types of ambient temperature change induced errors, such as change in radiation loss, not merely those losses dependent on changes in sensing element to wall temperature changes as is the case in U.S. Pat. 4,682,503. The improvement avoids the complexity of having to control the ambient temperature using thermoelectric cooling as described in U.S. Pat. 5,347,869. In addition, this improved calibration and operating method automatically compensates for the fact that the temperature coefficient of resistivity will be slightly different for the sensing element at operating temperature than for the compensating element at ambient temperature.

Claims

1. A heat loss gauge for measuring gas pressure in an environment, comprising:

a resistive sensing element (12) having a resistance which changes in response to ambient temperature changes;
 a compensating element (14) having a resistance which changes in response to ambient temperature changes;
 heating means (32) connected to the sensing element (12) for applying a heating voltage to the sensing element (12); and
 measuring means (48, 49) connected to the sensing element (12) and the compensating element (14) for determining gas pressure in the environment based on relative temperatures of the sensing element (12) and compensating element (14) and producing an electrical signal output indicative of the determined gas pressure,

wherein said heating means (32) operates to produce a fixed differential between the resistance of the sensing element (12) and a resistance of the compensating element (14) at ambient temperature without applying the heating voltage to the compensating element (14).

2. The heat loss gauge of claim 1, wherein the heating voltage is a DC voltage.
3. The heat loss gauge of claim 1, wherein the compensating element (14) has physical dimensions substantially equal to those of said sensing element (12) and is located in spaced relationship to said sensing element (12) and in the same plane as said sensing element (12) and is made of the same material as said sensing element (12).
4. The heat loss gauge of claim 1, wherein the gauge further comprises first and second thermally conductive elements (16, 16'), said first and second thermally conductive elements (16, 16') respectively having first and second surfaces proximate to said sensing element (12).
5. The heat loss gauge of claim 4, wherein said sensing element (12) has a spacing of from 0.0002 in. to 0.002 in. from each of said first and second surfaces.
6. The heat loss gauge of claim 5, wherein said spacings between said sensing element (12) and said surfaces are substantially equal.
7. The heat loss gauge of claim 4, wherein said surfaces of said thermally conductive elements (16, 16') are made of a material with a thermal conductivity greater than 0.25 watts/cm/K.
8. The heat loss gauge of claim 5, wherein the gauge further includes means (26, 28) for maintaining equal spacings between said sensing element (12) and said surfaces despite ambient temperature changes.

9. The heat loss gauge of claim 8, wherein said means (26, 28) for maintaining equal spacings includes a spring device for maintaining tension in said sensing element.
- 5 10. The heat loss gauge of claim 1, further comprising a voltage source (38) distinct from the heating means (32) for generating a signal current in the compensating element (14).
11. The heat loss gauge of claim 10, wherein the voltage source (38) for generating the signal current is an AC voltage source, and wherein the heating means (32) is a DC voltage source.
- 10 12. The heat loss gauge of claim 1, further comprising a processor (51) programmed to calculate gas pressure solely as a function with sole variables being a pair of parameters relating to current and voltage in the heat loss gauge.
13. The heat loss gauge of claim 1, wherein said gauge includes a bridge circuit (30) having four arms: a first arm including said sensing element (12), a second arm including said compensating element (14), and third and fourth arms, wherein said third and fourth arms have equal impedances, and the bridge circuit includes means (36) for preventing application to the compensating element (14) of said power applied to the sensing element (12) by the heating means (32).
- 15 14. The heat loss gauge of claim 13, further comprising a voltage source (38) distinct from the heating means (32) for generating a signal current in each of the four arms.
- 20 15. The heat loss gauge of claim 14, wherein the voltage source (38) for generating the signal current is an AC voltage source, and wherein the heating means (32) is a DC voltage source.
- 25 16. The heat loss gauge of claim 1, said gauge including a bridge circuit (30) having four arms: a first arm including said sensing element (12), a second arm including said compensating element (14), a third arm having a fixed third resistance element (19), and a fourth arm having a fixed fourth resistance element (17), wherein the resistance of the fixed fourth resistance element (17) multiplied by the resistance of the compensating element (14) at a given temperature multiplied by a temperature coefficient of the compensating element (14) for said given temperature is substantially equal to the resistance of said fixed third resistance element (19) multiplied by the resistance of the sensing element (12) multiplied by the temperature coefficient of the sensing element (12) for the given temperature.
- 30 17. The heat loss gauge of claim 16, wherein the bridge circuit (30) includes means (36) for preventing application to the compensating element (14) of the power applied to the sensing element (12) by the heating means (32).
- 35

Patentansprüche

- 40 1. Wärmeverlust-Meßeinrichtung zum Messen des Gasdrucks in einer Umgebung, mit:
 einem ohmschen Fühlerelement (12), das einen ohmschen Widerstand besitzt, der sich in Abhängigkeit von Umgebungstemperaturänderungen ändert;
 45 einem Kompensationselement (14) mit einem ohmschen Widerstand, der sich in Abhängigkeit von Umgebungstemperaturänderungen ändert;
 einem Heizmittel (32), das mit dem Fühlerelement (12) verbunden ist, um an das Fühlerelement (12) eine Heizspannung anzulegen; und
 Meßmitteln (48, 49), die mit dem Fühlerelement (12) und mit dem Kompensationselement (14) verbunden sind, um den Gasdruck in der Umgebung anhand relativer Temperaturen des Fühlerelements (12) bzw. des
 50 Kompensationselements (14) zu bestimmen und am Ausgang ein elektrisches Signal zu erzeugen, das den bestimmten Gasdruck angibt,
 wobei das Heizmittel (32) in der Weise arbeitet, daß es eine feste Differenz zwischen dem ohmschen Widerstand des Fühlerelements (12) und einem ohmschen Widerstand des Kompensationselements (14) bei Umgebungstemperatur erzeugt, ohne an das Kompensationselement (14) die Heizspannung anzulegen.
- 55 2. Wärmeverlust-Meßeinrichtung nach Anspruch 1, bei der die Heizspannung eine Gleichspannung ist.

3. Wärmeverlust-Meßeinrichtung nach Anspruch 1, bei der das Kompensationselement (14) physikalische Abmessungen hat, die im wesentlichen gleich jenen des Fühlerelements (12) sind, und sich in einer räumlichen Beziehung zu dem Fühlerelement (12) und in derselben Ebene wie das Fühlerelement (12) befindet und aus dem gleichen Werkstoff wie das Fühlerelement (12) hergestellt ist.
- 5 4. Wärmeverlust-Meßeinrichtung nach Anspruch 1, wobei die Maßeinrichtung ferner erste und zweite wärmeleitende Elemente (16, 16') umfaßt, wobei die ersten und zweiten wärmeleitenden Elemente (16, 16') erste bzw. zweite Oberflächen in der Nähe des Fühlerelements (12) besitzen.
- 10 5. Wärmeverlust-Meßeinrichtung nach Anspruch 4, bei der das Fühlerelement (12) einen Abstand im Bereich von 0,0002 Zoll bis 0,002 Zoll von jeder der ersten und zweiten Oberflächen hat.
6. Wärmeverlust-Meßeinrichtung nach Anspruch 5, bei der die Abstände zwischen dem Fühlerelement (12) und den Oberflächen im wesentlichen gleich sind.
- 15 7. Wärmeverlust-Meßeinrichtung nach Anspruch 4, bei der die Oberflächen der wärmeleitenden Elemente (16, 16') aus einem Werkstoff mit einer spezifischen Wärmeleitfähigkeit von mehr als 0,25 Watt/cm/K hergestellt sind.
8. Wärmeverlust-Meßeinrichtung nach Anspruch 5, wobei die Maßeinrichtung ferner Mittel (26, 28) enthält, die gleiche Abstände zwischen dem Fühlerelement (12) und den Oberflächen trotz Umgebungstemperaturänderungen aufrechterhalten.
- 20 9. Wärmeverlust-Meßeinrichtung nach Anspruch 8, bei der die Mittel (26, 28) zum Aufrechterhalten gleicher Abstände eine Federvorrichtung umfassen, die die Spannung im Fühlerelement aufrechterhalten.
- 25 10. Wärmeverlust-Meßeinrichtung nach Anspruch 1, die ferner eine Spannungsquelle (38) umfaßt, die von dem Heizmittel (32) verschieden ist und im Kompensationselement (14) einen Signalstrom erzeugt.
- 30 11. Wärmeverlust-Meßeinrichtung nach Anspruch 10, bei der die Spannungsquelle (38) für die Erzeugung des Signalstroms eine Wechselspannungsquelle ist und bei der das Heizmittel (32) eine Gleichspannungsquelle enthält.
- 35 12. Wärmeverlust-Meßeinrichtung nach Anspruch 1, die ferner einen Prozessor (51) umfaßt, der so programmiert ist, daß er den Gasdruck lediglich als Funktion ausschließlich von Variablen berechnet, die ein Parameterpaar bilden, das mit dem Strom und mit der Spannung in der Wärmeverlust-Meßeinrichtung in Beziehung steht.
- 40 13. Wärmeverlust-Meßeinrichtung nach Anspruch 1, wobei die Maßeinrichtung eine Brückenschaltung (30) mit vier Armen umfaßt: einen ersten Arm, der das Erfassungselement (12) enthält, einen zweiten Arm, der das Kompensationselement (14) enthält, und einen dritten und einen vierten Arm, wobei die dritten und vierten Arme gleiche Impedanzen besitzen, und wobei die Brückenschaltung Mittel (36) enthält, die das Anlegen der durch das Heizmittel (32) an das Fühlerelement (12) angelegten Leistung an das Kompensationselement (14) verhindern.
- 45 14. Wärmeverlust-Meßeinrichtung nach Anspruch 13, die ferner eine Spannungsquelle (38) enthält, die von dem Heizmittel (32) verschieden ist und der Erzeugung eines Signalstroms in jedem der vier Arme dient.
- 50 15. Wärmeverlust-Meßeinrichtung nach Anspruch 14, bei der die Spannungsquelle (38) für die Erzeugung des Signalstroms eine Wechselspannungsquelle ist und bei der das Heizmittel (32) eine Gleichspannungsquelle enthält.
- 55 16. Wärmeverlust-Meßeinrichtung nach Anspruch 1, wobei die Maßeinrichtung eine Brückenschaltung (30) mit vier Armen umfaßt: einen ersten Arm, der das Fühlerelement (12) enthält, einen zweiten Arm, der das Kompensationselement (14) enthält, einen dritten Arm, der ein festes drittes ohmsches Element (19) besitzt, und einen vierten Arm, der ein festes viertes ohmsches Element (17) besitzt, wobei der ohmsche Widerstand des festen vierten ohmschen Elements (17) multipliziert mit dem ohmschen Widerstand des Kompensationselements (14) bei einer gegebenen Temperatur multipliziert mit einem Temperaturkoeffizienten des Kompensationselements (14) für die gegebene Temperatur im wesentlichen gleich dem Widerstand des festen dritten ohmschen Elements (19) multipliziert mit dem ohmschen Widerstand des Fühlerelements (12) multipliziert mit dem Temperaturkoeffizienten des Fühlerelements (12) für die gegebene Temperatur ist.
17. Wärmeverlust-Meßeinrichtung nach Anspruch 16, bei der die Brückenschaltung (30) Mittel (36) enthält, die das

Anlegen der durch das Heizmittel (32) an das Fühlerelement (12) angelegten Leistung an das Kompensationselement (14) verhindern.

5 Revendications

1. Indicateur de perte de chaleur destiné à mesurer la pression de gaz dans un environnement, comprenant :

un élément de détection résistif (12) ayant une résistance qui change en réponse à des changements de la température ambiante ;
 un élément de compensation (14) ayant une résistance qui change en réponse à des changements de la température ambiante ;
 des moyens de chauffage (32) connectés à l'élément de détection (12) pour appliquer une tension de chauffage à l'élément de détection (12) ; et
 des moyens de mesure (48, 49) connectés à l'élément de détection (12) et à l'élément de compensation (14) pour déterminer la pression de gaz dans un environnement en se basant sur des températures relatives de l'élément de détection (12) et de l'élément de compensation (14) et produire une sortie de signal électrique représentatif de la pression de gaz déterminée,
 dans lequel lesdits moyens de chauffage (32) fonctionnent de manière à produire un différentiel fixe entre la résistance de l'élément de détection (12) et une résistance de l'élément de compensation (14) à température ambiante sans appliquer la tension de chauffage à l'élément de compensation (14).

2. Indicateur de perte de chaleur selon la revendication 1, dans lequel la tension de chauffage est une tension continue.

3. Indicateur de perte de chaleur selon la revendication 1, dans lequel l'élément de compensation (14) possède des dimensions physiques sensiblement égales à celles dudit élément de détection (12) et est situé dans une relation espacée avec ledit élément de détection (12) et dans le même plan que ledit élément de détection (12) et est fabriqué à partir du même matériau que l'élément de détection (12).

4. Indicateur de perte de chaleur selon la revendication 1, dans lequel l'indicateur comprend en outre des premier et second éléments thermiquement conducteurs (16, 16'), lesdits premier et second éléments thermiquement conducteurs (16, 16') ayant respectivement des première et seconde surfaces à proximité dudit élément de détection (12).

5. Indicateur de perte de chaleur selon la revendication 4, dans lequel ledit élément de détection (12) possède un espacement allant de 0,0002 pouce à 0,002 pouce à partir de chacun desdites première et seconde surfaces.

6. Indicateur de perte de chaleur selon la revendication 5, dans lequel lesdits espacements entre ledit élément de détection (12) et lesdites surfaces sont sensiblement égaux.

7. Indicateur de perte de chaleur selon la revendication 4, dans lequel lesdites surfaces desdits éléments thermiquement conducteurs (16, 16') sont fabriqués à partir d'un matériau dont la conductivité thermique est supérieure à 0,25 watts/cm/K.

8. Indicateur de perte de chaleur selon la revendication 5, dans lequel l'indicateur comprend en outre des moyens (26, 28) pour maintenir des espacements égaux entre ledit élément de détection (12) et lesdites surfaces en dépit des changements de la température ambiante.

9. Indicateur de perte de chaleur selon la revendication 8, dans lequel lesdits moyens (26, 28) destinés à maintenir des espacements égaux comprennent un dispositif à ressort pour maintenir la tension dans ledit élément de détection.

10. Indicateur de perte de chaleur selon la revendication 1, comprenant en outre une source de tension (28) distincte des moyens de chauffage (32) pour générer un courant de signal dans l'élément de compensation (14).

11. Indicateur de perte de chaleur selon la revendication 10, dans lequel la source de tension (38) destinée à générer le courant de signal est une source de tension alternative, et dans lequel les moyens de chauffage (32) sont une

source de tension continue.

12. Indicateur de perte de chaleur selon la revendication 1, comprenant en outre un processeur (51) programmé pour calculer la pression de gaz uniquement en tant que fonction avec des variables seules représentant une paire de paramètres en rapport avec le courant et la tension dans l'indicateur de perte de chaleur.

13. Indicateur de perte de chaleur selon la revendication 1, dans lequel ledit indicateur comprend un circuit en pont (30) ayant quatre branches : une première branche comprenant ledit élément de détection (12), une deuxième branche comprenant ledit élément de compensation (14), et des troisième et quatrième branches, dans lequel lesdites troisième et quatrième branches ont des impédances égales, et dans lequel le circuit en pont comprend des moyens (36) destinés à empêcher l'application sur l'élément de compensation (14) dudit courant appliqué à l'élément de détection (12) par les moyens de chauffage (32).

14. Indicateur de perte de chaleur selon la revendication 13, comprenant en outre une source de tension (38) distincte des moyens de chauffage (32) pour générer un courant de signal dans chacune desdites branches.

15. Indicateur de perte de chaleur selon la revendication 14, dans lequel la source de tension (38) destinée à générer le courant de signal est une source de tension alternative, et dans lequel les moyens de chauffage (32) sont une source de tension continue.

16. Indicateur de perte de chaleur selon la revendication 1, ledit indicateur comprenant un circuit en pont (30) ayant quatre branches : une première branche comprenant ledit élément de détection (12), une deuxième branche comprenant ledit élément de compensation (14), une troisième branche ayant un troisième élément de résistance fixe (19), et une quatrième branche ayant un quatrième élément de résistance fixe (17), dans lequel la résistance du quatrième élément de résistance fixe (17) multipliée par la résistance de l'élément de compensation (14) à une température donnée multipliée par un coefficient de température de l'élément de compensation (14) pour ladite température donnée est sensiblement égale à la résistance du troisième élément de résistance fixe (19) multipliée par la résistance dudit élément de détection (12) multipliée par le coefficient de température de l'élément de détection (12) pour la température donnée.

17. Indicateur de perte de chaleur selon la revendication 16, dans lequel le circuit en pont (30) comprend des moyens (36) destinés à empêcher l'application sur l'élément de compensation (14) du courant appliqué à l'élément de détection (12) par les moyens de chauffage (32).

FIG. 1A

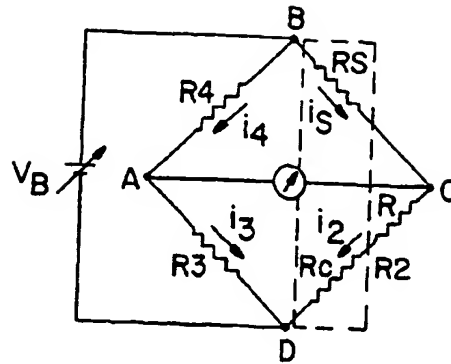


FIG. 1B

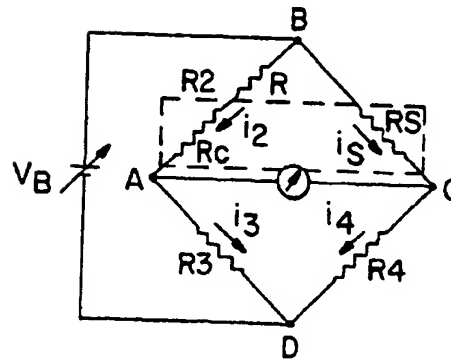


FIG. 2

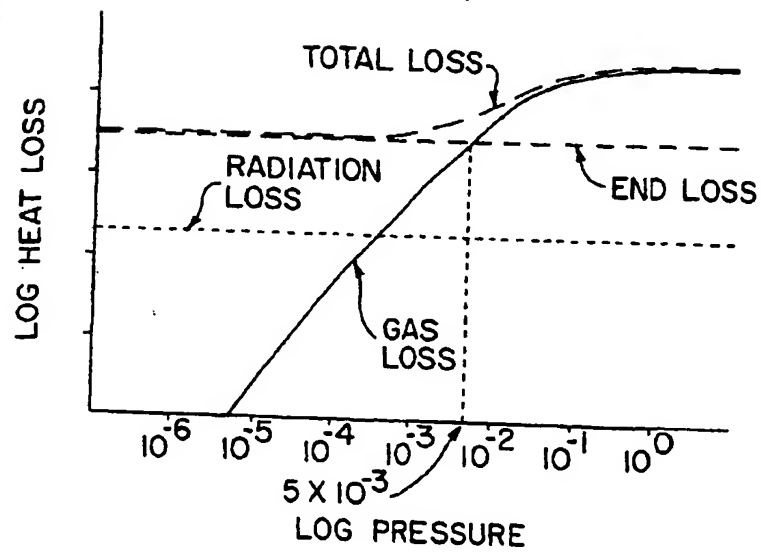


FIG. 3
PRIOR ART

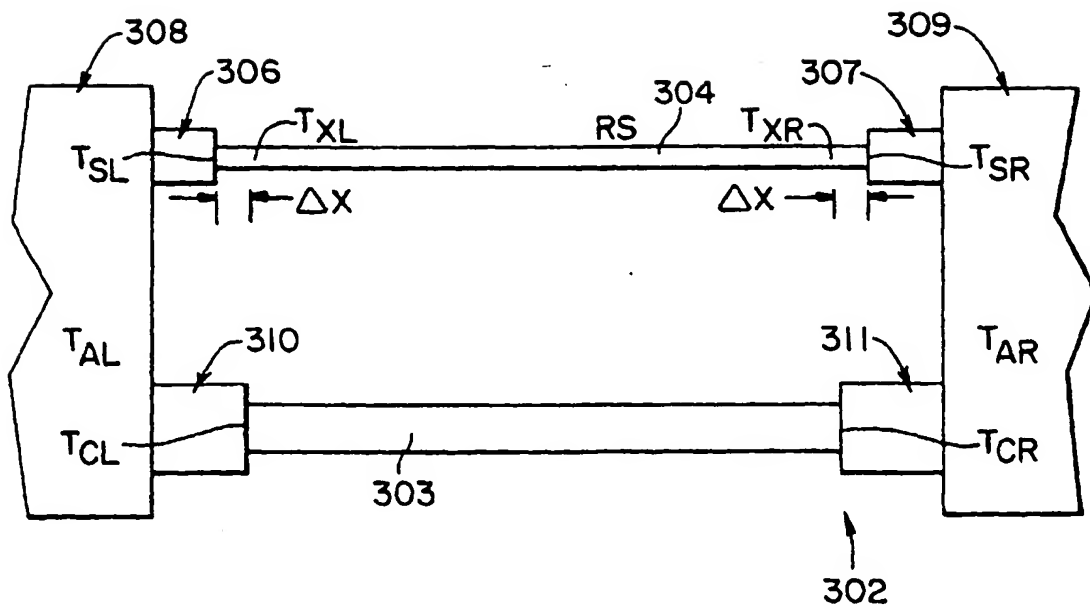


FIG. 4A

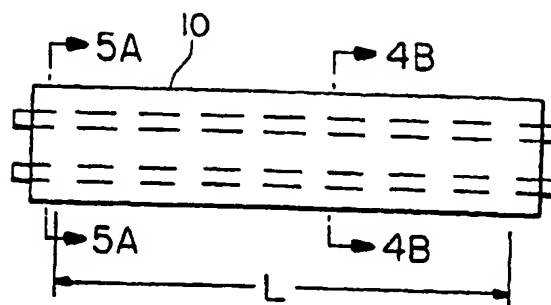


FIG. 4B

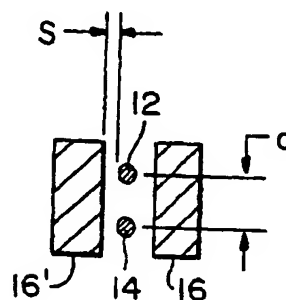


FIG. 5A

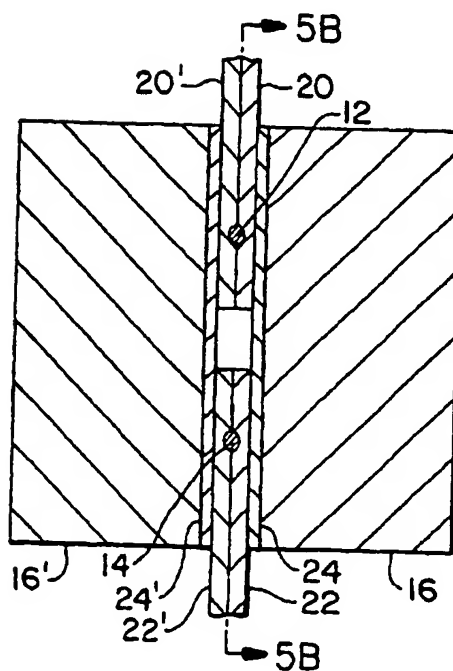


FIG. 5B

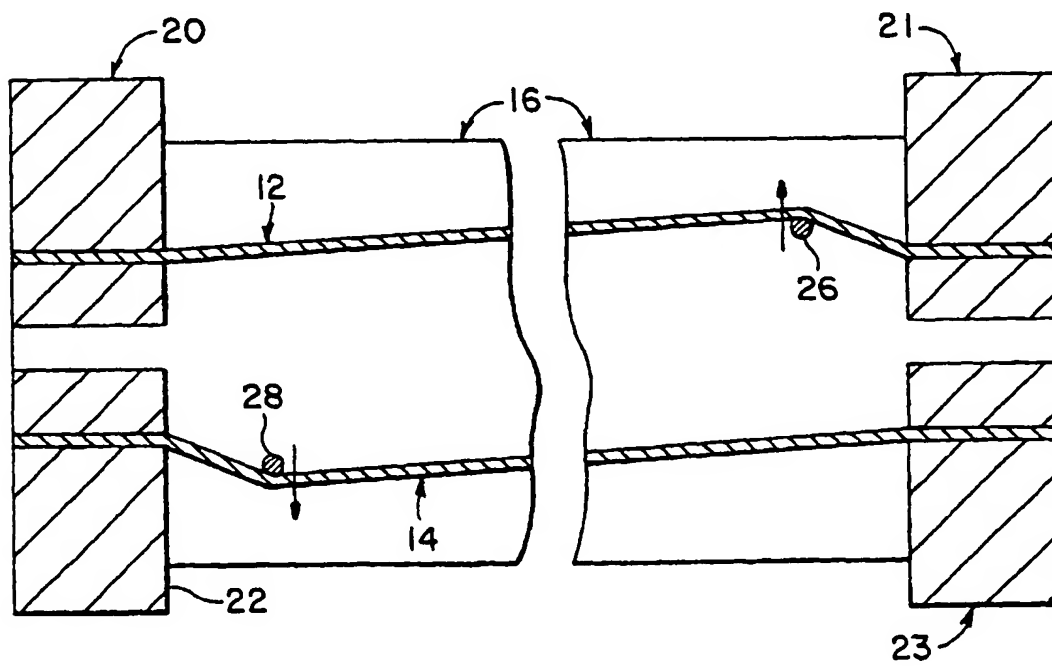


FIG. 6

